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IN THE UNITED STATES  
PATENT AND TRADEMARK OFFICE

In re Patent Application of:

<b>Inventor:</b>	Monroe et al	<b>Confirmation No:</b>	9548
<b>Serial No.</b>	10/677,539	<b>Examiner:</b>	Mai Huong C Tran
<b>Filed:</b>	Oct 02, 2003	<b>Group Art Unit:</b>	2818
<b>Title:</b>	MEMS Device And Method Of Forming MEMS Device		

Commissioner for Patents  
P O BOX 1450  
Alexandria VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

In response to your Office Action/Restriction Requirement dated September 21, 2004; Applicants affirm the election of Group II (Claims 1-27) without traverse.

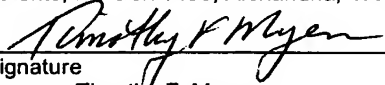
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Respectfully submitted,

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I hereby certify that this correspondence is being deposited on the date indicated below with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, PO Box 1450, Alexandria, VA 22313.

  
Signature  
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